

~~dimensional ion trap trapping ions in all axes including the axis which is generally parallel to the ion guide axis of symmetry, and wherein said two-dimensional ion guide functions to trap ions within said ion guide in directions orthogonal to said ion guide axis.~~

(d) means to controllably trap ions in said ion guide in the direction of said ion guide axis and controllably release ions from said ion guide into said pulsing region.

~~(d)~~ (e) means for pulsing said ions, transferred into said pulsing region, into said time-of-flight mass analyzer for mass analysis, and

(e) ~~(f)~~ means for detecting said mass analyzed ions with said detector.

Please add new claims 14 and 15 as follows:

14. (New) The apparatus of claim 11, further comprising an ion guide bias voltage applied to said ion guide, wherein said means to controllably trap ions in said ion guide in the direction of said ion guide axis and controllably release ions from said ion guide into said pulsing region comprises means to change the voltages on lens elements positioned near said ion guide exit relative to said ion guide bias voltage.

15. (New) The apparatus of claim 11, further comprising an ion guide bias voltage applied to said ion guide, wherein said means to controllably trap ions in said ion guide in the direction of said ion guide axis and controllably release ions from said ion guide into said pulsing region comprises means to change said ion guide bias voltage relative to voltages on lens elements positioned near said ion guide exit.

A COMPLETE LISTING OF THE CLAIMS FOLLOWS THE SIGNATURE PAGE OF THIS AMENDMENT.

CLAIMS:

Claims 1.-10. Cancelled

Amend Claim 11 as follows:

11. (Fifth Amendment) An apparatus for analyzing chemical species comprising:

(a) a time-of-flight mass analyzer with an ion pulsing region and a detector,

(b) an ion source for producing ions forming an ion beam from said chemical species,

(c) a two-dimensional multipole ion guide having an ion guide axis of symmetry and having an entrance end where ions enter said ion guide from said ion source and an exit end where ions exit said ion guide, ~~said two-dimensional multipole ion guide functioning as a two-dimensional ion trap~~; wherein said two-dimensional multipole ion guide comprises a plurality of spaced apart rods parallel to each other and to said ion guide axis and extending from said entrance end to said exit end, ~~said ion beam having an axis thereof which is parallel to said spaced apart rods, said two dimensional ion trap trapping ions in all axes including the axis which is generally parallel to the ion guide axis of symmetry, and wherein said two-dimensional ion guide functions to trap ions within said ion guide in directions orthogonal to said ion guide axis.~~

(d) means to controllably trap ions in said ion guide in th direction of said ion guide axis and controllably release ions from said ion guide into said pulsing region.

~~(d)~~ (e) means for pulsing said ions, transferred into said pulsing region, into said time-of-flight mass analyzer for mass analysis, and

~~(e)~~ (f) means for detecting said mass analyzed ions with said detector.

12. (Previously Amended) An apparatus as set forth in Claim 11 comprising means to control the timing of said means for pulsing said ions transferred into said pulsing region.

13. (Never amended) An apparatus as set forth in claim 11, wherein said ions in said multipole ion guide are scanned at a scan rate sufficiently rapid to prevent excessive charge buildup in said multipole ion guide.

14. (New) The apparatus of claim 11, further comprising an ion guide bias voltage applied to said ion guide, wherein said means to controllably trap ions in said ion guide in the direction of said ion guide axis and controllably release ions from said ion guide into said pulsing region comprises means to change the voltages on lens elements positioned near said ion guide exit relative to said ion guide bias voltage.

15. (New) The apparatus of claim 11, further comprising an ion guide bias voltage applied to said ion guide, wherein said means to controllably trap ions in said ion guide in the direction of said ion guide axis and controllably release ions from said ion guide into said pulsing region comprises means to change said ion guide bias voltage relative to voltages on lens elements positioned near said ion guide exit.